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FEB 11 2005

**OFFICE OF PETITIONS**

In re Application of :  
Yoichi Suzuki, et al. :  
Application No. 10/004,489 : ON PETITION  
Filed: October 23, 2001 :  
Attorney Docket No. SOEI/0011 :

This is a decision on the petition under 37 CFR 1.313(c)(3), filed by facsimile transmission on February 10, 2005, to withdraw the above-identified application from issue after payment of the issue fee.

Petitioner requests that the application be withdrawn from issue for express abandonment. See 37 CFR 1.313(c)(3).

The petition is **GRANTED**.

The application is hereby withdrawn from issue, and the abandonment is hereby recognized.

Telephone inquiries should be directed to the undersigned at (571) 272-3204.

The application is being referred to the Office of Publications to be processed as an abandoned file.

*Sherry D. Brinkley*  
Sherry D. Brinkley  
Petitions Examiner  
Office of Petitions  
Office of the Deputy Commissioner  
for Patent Examination Policy



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Date : February 11, 2005  
TO : Director, Office of Patent Publication  
FROM : Office of the Deputy Commissioner  
for Patent Examination Policy  
SUBJECT : Withdrawal from Issue of

Applicant(s) : Yoichi Suzuki, et al.  
Application No. : 10/004,489  
Filed : October 23, 2001

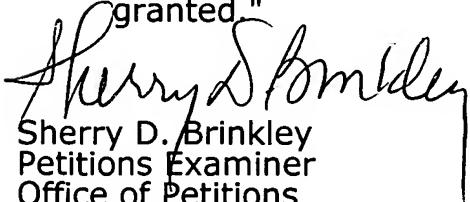
The above-identified application has been assigned Patent No. 6,855,644 and an issue date of February 15, 2005.

It is hereby directed that this application be withdrawn from issue at the request of the applicant.

Do not refund the issue fee.

The following erratum should be published in the Official Gazette if the above-identified application is published in the OG of February 15, 2005:

"All reference to Patent No. 6,855,644 to YOICHI SUZUKI, ET AL. of JAPAN for METHOD OF FORMING FILM, METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, AND FILM FORMING APPARATUS appearing in the Official Gazette of February 15, 2005, should be deleted since no patent was granted."



Sherry D. Brinkley  
Petitions Examiner  
Office of Petitions  
Office of the Deputy Commissioner  
for Patent Examination Policy

cc: Paul Harrison, Crystal Park 3-441 (FAX-306-2737)  
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